



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4076**
Yoshiharu ANDA et al. : Docket No. 2003-0955A
Serial No. 10/617,793 : Group Art Unit 2826
Filed July 14, 2003 : Examiner Tan N. Tran

SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action of May 24, 2004, please amend the above-identified application as follows.